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A. W. C.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/059,644
Filing Date April 13, 1998
Inventor Pai-Hung Pan
Assignee Micron Technology, Inc.
Group Art Unit 2822
Examiner M. Trinh
Attorney's Docket No. MI22-898
Title: Semiconductor Processing Methods of Forming a Conductive Gate and Line

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the reference listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

Citation of this reference is respectfully requested.

Respectfully submitted,

Date: Aug. 8, 2002

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